



PATENT
NPO0005-01

RECEIVED
APR 17 2003
GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group
Art Unit: 1762

Attorney
Docket No.: NPO0005-01

Applicant: Keiji Ishibashi

Invention: A HOT ELEMENT CVD
APPARATUS AND A
METHOD FOR REMOVING
A DEPOSITED FILM

Serial No.: 09/633,002

Filed: August 4, 2000

Examiner: W. Markham

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS correspondence
is being deposited with the United States Postal
Service as First Class Mail in an envelope addressed
to: Assistant Commissioner for Patents, Washington,
D.C. 20231, on: April 7, 2003

ANTHONY NIEWYK, REG. NO. 24, 871

Name of Registered Representative

Signature

April 7, 2003

Date

AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Responsive to the Office Action dated December 10, 2002, which had a period for
response set to expire on March 10, 2003, which period has been extended by the enclosed
Petition For Extension Of Time to expire on April 10, 2003, Applicant hereby submits the
following amendment: